

**Notice of References Cited**

Application/Control No.

10/808,840

Applicant(s)/Patent Under  
Reexamination  
CITRYNELL ET AL.

Examiner

Chen-Wen Jiang

Art Unit

3744

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0177642 A1	09-2004	Citrynell et al.	062/457.3
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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